

SECTOR #



35C.1402

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
: Examiner: Not Assigned
TAMAKI KOBAYASHI ET AL.)
: Group Art Unit: 2879
Application No.: 09/440,535)
: Filed: November 16, 1999)
: For: SUBSTRATE FOR ELECTRON)
: SOURCE, ELECTRON SOURCE :
: AND IMAGE FORMING)
: APPARATUS, AND :
: MANUFACTURING METHOD)
: THEREOF : Date: February 29, 2000

Box Missing Part
The Assistant Commissioner for Patents
Washington, D.C. 20231

**ATTENTION: APPLICATION PROCESSING DIVISION, SPECIAL
PROCESSING AND CORRESPONDENCE BRANCH**

RESPONSE TO NOTICE TO FILE MISSING
PARTS OF APPLICATION - FILING DATE GRANTED

Sir:

In response to the NOTICE TO FILE MISSING PARTS OF
APPLICATION - FILING DATE GRANTED mailed December 29, 1999,

03/06/2000 TLW11 00000059 09440535

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150.00 00

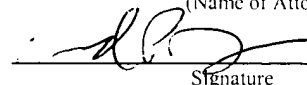
I hereby certify that this correspondence is being deposited with the
United States Postal Service as first-class mail in an envelope addressed
to: Assistant Commissioner for Patents, Washington, D.C. 20231 on

February 29, 2000

(Date of Deposit)

Leonard P. Diana

(Name of Attorney for Applicant)



Signature

February 29, 2000

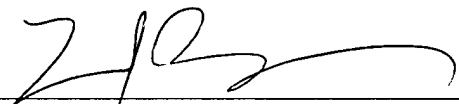
Date of Signature

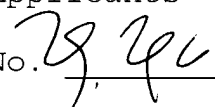
enclosed please find an executed Declaration/Power of Attorney form, together with the surcharge fee of \$130.00.

The Assistant Commissioner is authorized to charge any additional fees or credit any overpayment to Deposit Account No. 06-1205. A duplicate copy of the document is attached for that purpose.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should be directed to our new address given below.

Respectfully submitted,



Attorney for Applicants
Registration No. _____
28,464

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